



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 09/896,249 Confirmation No.: 9186
First Named Inventor: Pei, Shiyu Filing Date: 28 June 2001
Group Art Unit: 2879 Examiner: Ramsey, K. J.
Atty. Docket No.: CT-M158 US
Title: Cleaning of Cathode-Ray Tube Display
Assignee(s): Candescent Technologies Corporation and
Candescent Intellectual Property Services, Inc.

Mountain View, California
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AMENDMENT UNDER 37 CFR 1.116

Sir:

Responsive to Office Action mailed 15 January 2004 and under the provisions of 37 CFR 1.116, please amend the above patent application in the following manner so as to place the application in a better form for appeal.

IN THE SPECIFICATION

Amend paragraph 65 as follows:

[0065] Fig. 3 illustrates an implementation of inert-gas reservoir 28 consisting of inert-gas compound 70. Candidates for inert-gas compound 70 include argon hydrofluoride (ArHF), krypton fluoride (KrF₂), xenon fluoride (XeF₂), xenon platinum fluoride (XePtF₆), xenon hydrocyanide (XeHCN), and xenon hydrochloride (XeHCl). These inert-gas compounds are generally unstable and slowly dissociate to release the replacement inert gas. Although Fig. 3 illustrates ~~does not indicate any supporting structure for~~ inert-gas compound

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70 as being in contact with backplate 40, some of the exemplary inert-gas compounds identified here are liquids or gases, and thus need further supporting/retaining ~~supporting~~ structures such as a piece of material that adsorbs or/and absorbs compound 70 or a container that holds compound 70.

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